L Number	Hits	Search Text	DB	Time stamp
1	48	(APCVD ((CVD (chemical adj vapor adj deposit\$3)) near12	USPAT;	2004/10/09 18:02
		(atmospheric "760 Torr" "760 mm Hg")) ) near12	US-PGPUB;	
		((amorphous adj (silicon Si)) "a-Si")	EPO; JPO;	
			DERWENT:	
			IBM TDB	
2	0	(laser irradiat\$4) near15 (crystaliz\$5 crystalis\$5) near15	USPAT:	2004/10/09 18:21
		((atmospheric adj pressure) "760 Torr" "760 mm Hg" "1 atm")	US-PGPUB:	
			EPO: JPO:	
			DERWENT;	
+			IBM TDB	
3	2	(crystaliz\$5 crystalis\$5) near15 ((atmospheric adj pressure)	USPAT:	2004/10/09 18:21
	_	"760 Torr" "760 mm Hg" "1 atm")	US-PGPUB:	
		, , , , , , , , , , , , , , , , , , ,	EPO: JPO:	
			DERWENT:	
			IBM TDB	